

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*

Docket No.

NEC 05P015

Application Number

10/599,609

Applicant(s)

OOHASHI et al

Filing Date

10/03/06

Group Art Unit

2814

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS*(Including Author, Title, Date Pertinent Pages, ETC.)*

Fujikata, et al., "Surface Plasmon Enhancement Effect and Its Application to Near-Field Optical Recording", Trans. Magn. Soc. Jpn., Vol. 4, No. 4-2, 2004.

"Transactions of the Magnetics Society of Japan", Selected Papers from Magneto-Optical Recording International Symposium, Vol. 4, No. 4-2, No. 15 (2004) <http://www.nil.ac.jp/msj2>, November 2004.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.